

In re application of:

KIRA et al.

Serial No. 08/393,677

Filed: February 24, 1995

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1005

Group Art Unit: 1107

Examiner: D. Graybill

For: METHOD AND APPARATUS FOR FABRICATING SEMICONDUCTOR DEVICE

RESPONSE TO REQUIREMENT FOR RESTRICTION

Honorable Commissioner of Patents and Trademarks Washington, D. C. 20231

October 24, 1995

sir:

In response to the Office Action, dated September 21, 1994, extended for one month from October 21, 1995 to November 21, 1995, by petition for one month extension, with extension fee, filed herewith, Applicants designate, without traverse, Group I, claims 1-8, drawn to a process.

Non-designated claims 9 and 10, drawn to an apparatus, are retained herein pending Applicants' decision as to the filing of a divisional application.

Action on the merits of designated claims 1-8, at an early date, is requested.

Respectfully submitted,

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By:

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